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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/046,330
Filing Date October 25, 2001
Inventor Wuwen Yi et al.
Assignee Honeywell International, Inc.
Priority Group Art Unit 2818
Priority Examiner P. T. Dang
Attorney's Docket No. JM32810-CIP
Title: Physical Vapor Deposition Targets

Appointment of Practitioners under 37 CFR 1.34

To: Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

As authorized under 37 CFR § 1.34, in conjunction with my existing power of attorney with respect to the above identified application, I hereby appoint the following practitioners to prosecute the above identified patent application, and to transact all business in the Patent and Trademark Office connected therewith:

Melanie L. Brown, (Reg. No. 31,592), Shannon Votava, (Reg. No. 48,272)
and Jennifer J. Taylor, (Reg. No. 48,711).

Please enter the above changes into the subject application file.

Respectfully,

Dated: 4/17/02

By: [Signature]

David G. Latwesen, Ph.D.
Reg. No. 38,533